# THERMAL CHARACTERIZATION OF IRON OXIDE FILMS\*

P. K. GALLAGHER, W. ROBERT SINCLAIR, R. A. FASTNACHT AND J. P. LUONGO Bell *Laboratories, Murray Hill, N. J. 07974 (U.S.A.)* **(Received 11 December 1972)** 

### **ABSTRACT**

Films of iron oxide were prepared by chemical vapor deposition techniques (CVD) **and by sputtering in an oxygen atmosphere\_** These **films were examined by**  thermogravimetry, differential thermal analysis, evoived gas analysis, infrared spectroscopy, Mössbauer spectroscopy, and X-ray diffraction analysis. CVD films were found to contain 5-10% divalent iron and large amounts of chemisorbed and chemically bonded  $CO<sub>2</sub>$ . The carbonate ion was decomposed by heating to 500 °C and the film converted to well crystallized  $\alpha$ -Fe<sub>2</sub>O<sub>3</sub>. The chemisorbed CO<sub>2</sub> was released on further heating to 1000 °C. The films sputtered in  $O_2$  are already largely  $x-Fe<sub>2</sub>O<sub>3</sub>$  when prepared and become well crystallized by 500 °C with much smaller quantities of chemisorbed gases.

### **IXIRODUCTION**

It has recently been shown that  $Fe<sub>2</sub>O<sub>3</sub>$  films made by iow temperature reaction of Fe(CO), and  $O_2$ <sup>1</sup> can be made insoluble in 6 M HCI by treatment with either an electron beam<sup>2</sup> or with focussed light from an argon ion laser<sup>3</sup>. The Fe<sub>2</sub>O<sub>3</sub> film prepared in this way can, therefore, be viewed as either an electron resist or a photoresist. As a result of these procedures one can anticipate simplification end improvements in making see-through photomasks.

It has been noted that an initiaIIy amorphous **Fe,O, film is crystallized as a**  result of either the electron beam or laser treatment. Bagley<sup>4</sup> has recently discussed the kinetics of such amorphous to crystalline transitions. In order to gain greater insight into the process involved in thermal treatments of  $Fe<sub>2</sub>O<sub>3</sub>$  films, we have made measurements on chemical vapor deposition techniques **(CVD)** and sputtered films by evolved gas analysis (EGA), differential thermal analysis (DTA), thermogravimetry (TG), infrared spectroscopy, Mössbauer spectroscopy, and X-ray diffraction. **These measurements and discussion of the results are the subject matter of this report.** 

### **EXPERIMENTAL PROCEDURES**

### **Preparation of films**

In general, CVD films were prepared using techniques outlined by Sullivan<sup>5</sup>.  $CO<sub>2</sub>$  was bubbled through Fe(CO)<sub>5</sub> and the resulting gaseous mixture was merged **\*Presented zt the 4th North American Axlysis Society Meeting, \Vorcester, Mass., June I3-15,1973.** 

with flowing O<sub>2</sub> near the heated substrate. Deposition temperatures as a function of heater voltage were determined by calibration runs using a thermocouple attached to the substrate surface. For EGA determinations some  $Fe<sub>2</sub>O<sub>3</sub>$  films on soda lime glass substrates were used. These samples were obtained from Towne Laboratories, Somerville, N. J. For most runs Coors alumina (AD995) thin film substrates were -used to minimize the possibility of CO<sub>2</sub> evolution from the substrate material. No **important substrate effects were noted. CVD Fe<sub>2</sub>O<sub>3</sub> was deposited onto single crystal** NaCl discs for the DTA and TG determinations. These were usually thick films and were detached by scraping lightly with a razor blade.

Some films for DTA and TG studies were prepared by sputtering in O<sub>2</sub>. The experimental apparatus and conditions have been described elsewhere<sup>6</sup> with one important deviation from these conditions. The NaCl substrate used was attached to a liquid  $N_2$ -cooled holder to minimize crystallite growth.

# *Thermogracimetry*

**A Perkin-EImer thermobalance was used which had been modified to provide**  digital output on punched paper tape<sup>7</sup>. Temperature calibration was based upon the use of magnetic standards as previously described'. The heating rate was nominaliy 2.5 °C min<sup>-1</sup>. Air was passed over the sample through the approximately 15 mm in diameter tube at a rate of 30 ml min<sup>-1</sup>.

The samples were in the form of small, very light flakes of film and it was necessary to use a platinum mesh cover for the platinum sample pan\_ SampIes weighed in the range of 3-10 mg depending **upon the avaihbility and packing of** the material.

# *DifferentiaZ thermal anal'sis*

A Dupont thermolyser was used with a heating rate of  $10^{\circ}$ C min<sup>-1</sup> and an air atmosphere at a flow rate of 20 ml  $min^{-1}$ . Samples of 5-15 mg were placed in platinum cups and an empty cup served as the reference.

# *Erolced gas analysis*

Approximately 50 cm<sup>2</sup> samples of the CVD films on alumina or glass were broken into small pieces and placed in a platinum tube which had been previously baked at 1000 °C and  $1 \times 10^{-6}$  mm Hg. The sample chamber was evacuated to about  $1 \times 10^{-6}$  mm Hg and then heated at approximately 5 °C min<sup>-1</sup> with continued pumping. A Veeco SPI-IO residual gas analyzer in the system was repeatedly scanned over the range of IO-55 amu. The output from the analyzer and a Pt/Pt-10% Rh thermo**couple in contact with the sample were recorded on a two pen recorder.** 

## *Miksbauer spectroscopy*

A constant **acceleration spectrometer simiIar to that** described by Wertheim and Herber<sup>8</sup> was used. The source was  $57Co$  in Pd. Calibration was based upon the ground state splitting of  $57$  Fe. A value of 3.92 mm sec<sup>-1</sup> obtained from NMR and Mössbauer measurements was used<sup>9,10</sup>. Isomer shifts of magnetically split spectra **were determined from the centroid of the lines.** 

## *Infrared specrroscopy*

**Both sputtered and CVD films were deposited on single crystal NaCI. SampIes were removed from the NaCl prior** to **heating to 1000 'C for IO min and KBr pellets were prepared from both the heated and unheated powders. The infrared spectra of both the KBr pellets and supported films were measured using a Perkin-Elmer Model 421 grating instrument.** 

## *X-ray dtrraction*

**A G.E. Mode1 XRD-3 diffractometer and CrK, radiation was empIoyed\_ Samples of both CVD and sputtered films were deposited on gIass slides and their diffraction patterns determined.** 

## **RESULTS AND DISCUSSION**

Precise correlation of temperature between the various experimental techniques **are impossibie due to differences in heating rates. Fig 1 shows TG traces for a CVD** 



Fig. 1. Thermogravimetric curves of films which convert to  $\alpha$ -Fe<sub>2</sub>O<sub>3</sub>.

film prepared at 100°C and for **a sample of sputtered fiIm. The DTA patterns for the**  same samples are shown in Fig. 2. The sputtered film shows relatively little weight loss while the CVD film loses about 9 wt\_ % below 45O"C and a clear exothermic peak for the CVD film in the region of  $390-440^{\circ}$ C. There is a much weaker exctherm for the sputtered film in the same temperature region. There are no other peaks for either material from room temperature to 900 'C.



Fig. 2. Differential thermogravimetric curves of films which convert to  $\alpha$ -Fe<sub>2</sub>O<sub>3</sub>.

X-ray diffraction patterns obtained from both types of flim heated to 500 "C indicate a sharp pattern of  $\alpha$ -Fe<sub>2</sub>O<sub>3</sub>. At room temperature the sputtered film gives a diffuse weak pattern corresponding to  $\alpha$ -Fe<sub>2</sub>O<sub>3</sub>, while the CVD film yields no discernible peaks.

It appears then that the sputtered film is basically small crystalline  $\alpha$ -Fe<sub>2</sub>O<sub>3</sub> at room temperature and upon heating undergoes only a slight weight loss which is probably associated with adsorbed gases on the large surface area. These gases are desorbed due to both the elevated temperatures and reduction in surface area. The CVD film on the other hand appears to be an amorphous or microcrystalline material with chemically bonded as well as physically adsorbed gaseous species.

Inspection of the EGA data indicates that some water and large amounts of CO<sub>2</sub> are evolved as the temperature is raised. Figure 3 shows a plot of the relative intensity of the mass  $(CO<sub>2</sub>)$  peak as a function of temperature. The peak around 400 °C correlates well with the weight loss and DTA peak. There is also a high temperature peak correlating with the onset of a second weight loss at 700 "C and the change in sIope of the DTA curve.

Selected infrared spectra are presented in Fig. 4. The spectrum of the sputtered film (4a) is nearly free of absorptions as would be expected. The weak absorption at  $3400 \text{ cm}^{-1}$  is associated with hydroxide ion, which is always present at about this strength in KBr pellets. Since the absorption coefficient of hydroxide ion is very



Fig. 3. Relative intensity of the mass 44 peak evolved as a function of temperature.



Fig. 4. Infrared spectra of some films which convert to x-Fe<sub>2</sub>O<sub>3</sub>. a, sputtered in O<sub>2</sub>, unheated, KBr pellet; b, CVD, unheated, on NaCl; c, CVD, heated to 500°C, on NaCl; d, CVD, heated to 1000°C, **KBr pellet.** 

**strong, it is assumed that the amount of hydroxide ion introduced with the sample is small\_** 

**The CVD film at room temperature (4b) shows (1) two strong absorptions at 1485 and I375 cm-' which are indicative of carbonate ion, (2) an absorption around**  2340 cm<sup> $-1$ </sup> where molecular carbon dioxide absorbs, and (3) a band at 3400 cm<sup> $-1$ </sup> attributable to hydroxide ions. When heated to 500-700 °C (4c) the absorptions due to carbonate (1485 and 1375 cm<sup>-1</sup>) ions virtually disappear while that attributed to **carbon dioxide** (2340 cm- ') **persists. After the sample is heated to 1000 "C (4d) these**  absorptions are no longer present. It was necessary to remove the CVD film from the **NaCI substrate prior to heating it to 1000°C since this is above the melting point of**  NaCl and then to run the film as a KBr pellet after heating. Consequently, the absorption at 3400 cm<sup>-1</sup> is again typical of hydroxide ion in KBr.



Fig. 5. Mössbauer spectra of CVD films. a, as prepared, RT; b, heated to 5000°C, RT.

**M** Mossbauer spectra of the CVD films are shown in Fig. 5. The as deposited film consists primarily of a quadrupole doublet having an isomer shift of  $+0.19$  mm sec<sup>-1</sup> and a splitting of  $1.07 \text{ mm sec}^{-1}$ . The isomer shift is typical of trivalent iron. The **quadrupoIe splitting is very large and indicative that the iron sites in this amorphous or microcrystalline film are highly asymmetric with respect to the electrical charge distribution surrounding the iron nucleous. There is also some divalent iron present** 

as indicated by the small shoulder at about  $+2.0$  mm sec<sup>-1</sup>. This is undoubtedly one half **of quadrupole split doublet whose other haIf is concealed within the much Iarger trivalent absorption.** 

When the film has been heated to  $500^{\circ}$ C the resulting Mössbauer spectrum is that of well crystallized  $\alpha$ -Fe<sub>2</sub>O<sub>3</sub>.

Figure 6 shows MSssbauer spectra of the unheated sputtered film. The spectrum at room temperature clearly shows two separate patterns each exhibiting the six-Iine pattern associated with magnetic hyperfine interaction. The narrow line pattern has an isomer shift of  $+0.17$  mm sec<sup>-1</sup> and a hyperfine splitting of 509 koe and is ascribed



**Fi\_e 6\_ Mbssbauer spectra of sputtered films. a, as prepared, RT; b, as prepared, 7s K.** 

to the crystallized  $\alpha$ -Fe<sub>2</sub>O<sub>3</sub> evident in the X-ray pattern of this sample. The much broader pattern has an isomer shift of  $+0.19$  mm sec<sup>-1</sup> and a hyperfine splitting of 423 koe. The isomer shift value clearly establishes it to be trivalent iron. This material is either a more finely divided  $\alpha$ -Fe<sub>2</sub>O<sub>3</sub> which is approaching superparamagnetism or a second phase of trivalent iron.

The spectrum at 78 K shows that the broad spectrum at room temperature has sharpened up considerably and the magnetic hyperfine splitting has increased to almost match the well crystallized  $\alpha$ -Fe<sub>2</sub>O<sub>3</sub> portion. This suggests that the material is a more finely divided  $\alpha$ -Fe<sub>2</sub>O<sub>3</sub>.

#### **CONCLUSIONS**

Based on the body of experimental data the conclusion is that films sputtered in oxygen are to a large degree crystallized iron oxide. Upon heating to 1000 "C there is a small weight loss, about 1.5 wt %, due to the decrease in adsorbed gases resulting from the reducing in surface area of the oxide. By  $500^{\circ}$ C the film is completely crystallized  $\alpha$ -Fe<sub>2</sub>O<sub>3</sub>.

The CVD fiIms are originally an amorphous or micro-crystalline film which contains predominantly trivalent iron but has approximately  $5-10%$  of divalent iron. There are Iarge amounts of carbon dioxide and some water present corresponding to an approximate formula of  $Fe<sub>2</sub>O<sub>3</sub> \cdot \frac{1}{2}CO<sub>2</sub>$  assuming that the weight loss is exclusively  $CO<sub>2</sub>$ . The  $CO<sub>2</sub>$  is present both as carbonate ion and apparently also as chemisorbed CO<sub>2</sub>. The amount of divalent iron and carbonate ion may be related.

Upon heating CVD films to 500 °C the carbonate ion is decomposed and  $CO<sub>2</sub>$  is evolved along with the water. The film is converted to crystalline  $\alpha$ -Fe<sub>2</sub>O<sub>3</sub> although the bulk of the chemisorbed  $CO<sub>2</sub>$  is retained. This  $CO<sub>2</sub>$  is then evolved as the temperature is raised and the surface area of the oxide decreases due to sintering- Several investigations<sup>2, 5, 11</sup> have previously shown that the crystallization of CVD films occurs in this temperature range accompanied by a reduction of solubility in  $6 \, M$  HCl. These measurements now show that there is a concomitant loss of significant amounts of  $CO<sub>2</sub>$  from the film.

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